# Ch4: Sensors – Part 2

#### **Contents:**

Stress, Strain, and Force

**Light Sensors** 

Temperature

Inputting Data by Switches

Selection of Sensors

Amin Fakhari, Fall 2023



Selection of Sensors

# Stress, Strain, and Force

Stress, Strain, and Force

### **Stress & Strain Measurement**

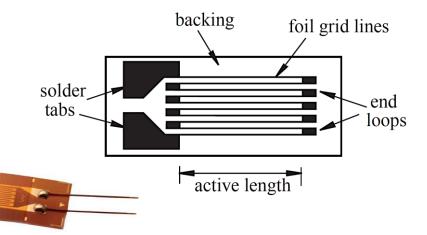
- Measurement of stress in a mechanical component is important when assessing whether the component is subjected to safe load levels.
- Experimental stress analysis (e.g., with strain gages) and analytical or numerical stress analysis (e.g., with finite element analysis) are both important and complementary to design reliable mechanical parts.
- Stress and Strain measurements can also be used to indirectly measure other physical quantities such as force (by measuring strain of a flexural element), pressure (by measuring strain in a flexible diaphragm), temperature (by measuring thermal expansion of a material), and displacement.

Stress, Strain, and Force

# Strain Gage (Metal Foil Type)

**Electrical Resistance Strain Gage** is the most common sensor used to measure strain. It consists of a **thin foil of metal** (usually Constantan) deposited as a grid pattern onto a thin plastic backing material (usually polyimide). The foil pattern is terminated at both ends with large metallic pads that allow leadwires to be easily attached with solder.

- The gage is adhesively bonded directly to the component (usually with epoxy).
- When the component is loaded, the metal foil deforms, and the resistance changes. If this resistance change is measured accurately, the average of the strain on the small surface of the component can be determined.



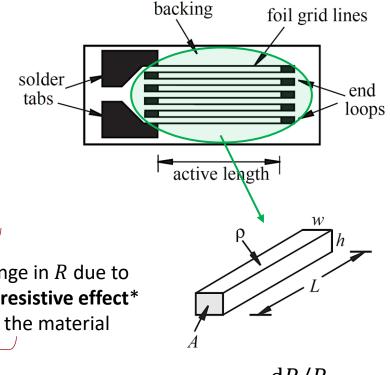
• Making measurements where **stress gradients are large** (e.g., stress concentration) can yield **poor results**.

Stress, Strain, and Force



# Strain Gage (Metal Foil Type)

The **metal foil** grid lines in the **active portion** of the gage can be approximated by a single rectangular conductor (effects of gage end loops and solder tabs are negligible). Thus, total resistance:



$$R = \rho \frac{L}{A} \qquad \Rightarrow \qquad$$

 $\rho$ : foil metal resistivity

ν: Poisson's ratio

Change in 
$$R$$
 due to increased  $L$ 

and decreased A

Change in *R* due to piezoresistive effect\* in the material

All three terms are approximately constant over the operating range of typical strain gage metal foils:

Gage Factor  $(GF) \cong 2$ 

$$\Rightarrow GF = \frac{dR/R}{\varepsilon_{\text{axial}}}$$

<sup>\*</sup> Piezoresistive Effect is a change in the electrical resistivity of a semiconductor or metal when mechanical strain is applied.

# Strain Gage (Metal Foil Type)

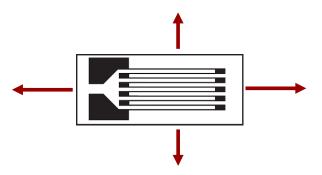
• If a 120 $\Omega$  strain gage with gage factor 2.0 is used to measure a strain of 100 µE (microstrain), how much does the resistance of the gage change from the unloaded state to the loaded state?

$$\Delta R = R \cdot GF \cdot \varepsilon$$

$$\Delta R = 120(\Omega) \times 2.0 \times 0.000100 = 0.024 \Omega$$

• Strain gage suppliers also report a **Transverse Sensitivity** for the gage, which is a number that predicts the gage's sensitivity to **transverse strains** (those perpendicular to the measuring axis of the gage). The transverse sensitivity is usually close to 1%.

For example, a gage experiencing 50 με in the axial direction and 100 με in the transverse direction with a transverse sensitivity of 1% will sense 51  $\mu\epsilon$  (50+1% of 100).



Stress, Strain, and Force

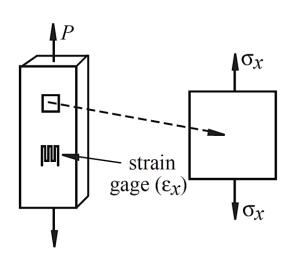
Stress, Strain, and Force

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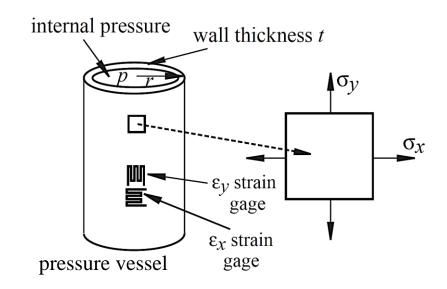
### Strain Gage in Uniaxial & Biaxial Loading

#### **Uniaxial Loading**



$$\sigma_{x} = E \varepsilon_{x}$$

**Biaxial Loading** (loading in two orthogonal directions)



$$\varepsilon_{x} = \frac{\sigma_{x}}{E} - v \frac{\sigma_{y}}{E} \qquad \varepsilon_{y} = \frac{\sigma_{y}}{E} - v \frac{\sigma_{x}}{E}$$

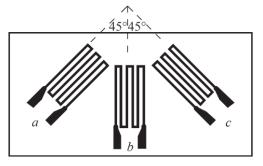
### **Strain Gage in Complex Loading & Geometry**

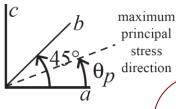
For **Complex Loading and Geometry**, three gages (known as strain gage **rosette**) is mounted in three different directions to find the magnitude and direction of the **Principal Stresses** 

 $(\sigma_{\max,\min}, \tau_{\max}).$ 

Stress, Strain, and Force

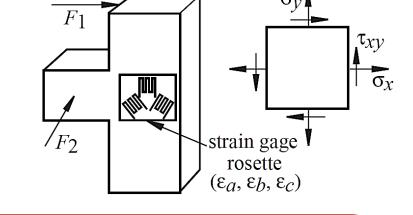
 The most common rosette patterns is rectangular strain gage:

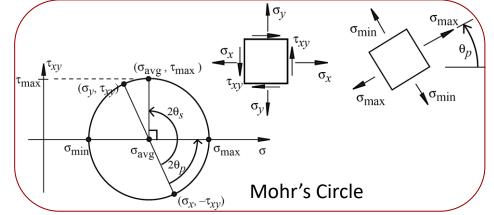




$$\sigma_{\text{max, min}} = \frac{E}{2} \left[ \frac{\varepsilon_a + \varepsilon_c}{1 - \nu} \pm \frac{1}{1 + \nu} \sqrt{2(\varepsilon_a - \varepsilon_b)^2 + 2(\varepsilon_b - \varepsilon_c)^2} \right]$$

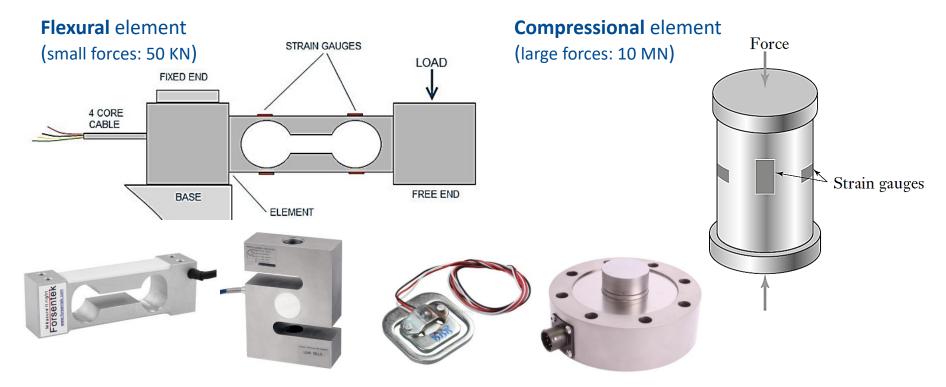
$$\tau_{\text{max}} = \frac{E}{2(1+v)} \sqrt{2(\varepsilon_a - \varepsilon_b)^2 + 2(\varepsilon_b - \varepsilon_c)^2}$$
$$\tan 2\theta_p = \frac{2\varepsilon_b - \varepsilon_a - \varepsilon_c}{\varepsilon_b - \varepsilon_a}$$





# **Force Sensor Using Strain Gage**

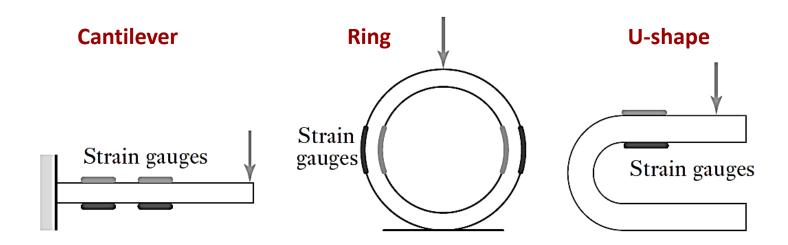
**Load Cell** is a sensor used to measure **force**. It contains an internal **flexural or compressional element**, usually with several **strain gages** mounted on its surface. The flexural element's shape is designed so that the strain gage outputs can be easily related to the applied **force**. Load cells are also used in **weight scales**.



Stress, Strain, and Force

# Displacement Sensor Using Strain Gage

Displacement can be measured by attaching strain gauges to flexible elements in the form of **Cantilevers**, **Rings**, or **U-shapes**.



• When the flexible element is bent or deformed, the resistance of strain gauges change. This change is a measure of the displacement or deformation of the flexible element.

Stress, Strain, and Force



Selection of Sensors

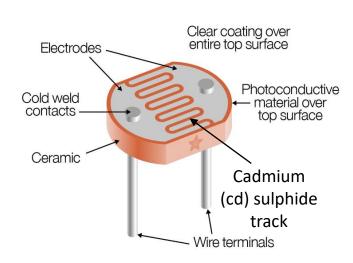
# **Light Sensors**

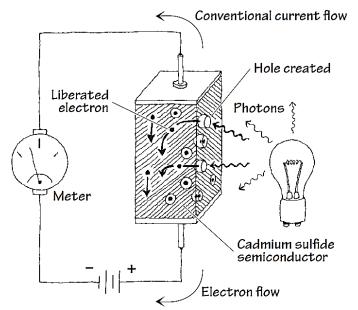
Stress, Strain, and Force

### **Photoresistor**

A **Photoresistor** is a light-controlled variable resistors whose resistance depends on the **intensity of the light** falling on it, **decreasing linearly** as the intensity **increases**. The sensitivity depends on the **wavelength** of the light.







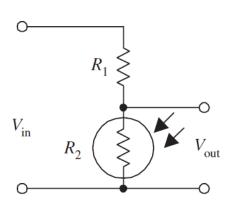
**Light Sensors** 

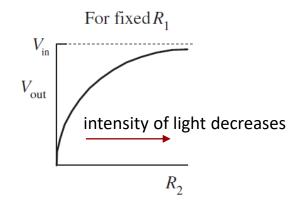
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Photoresistors are made from a special kind of **semiconductor** crystal, such as <u>Cadmium sulfide</u> (for **light**) or <u>Lead sulfide</u> (for **infrared**). When this semiconductor is placed in the dark, electrons within its structure do not want to flow through the resistor. However, when illuminated, incoming photons of light collide with the **bound electrons**, stripping them from the binding atom, thus creating a hole in the process. These liberated electrons can now contribute to the current flowing through the device (the resistance goes down).

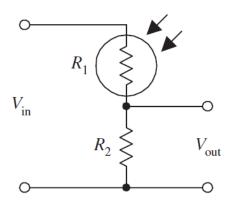
### **Application: Light-Sensitive Voltage Divider**

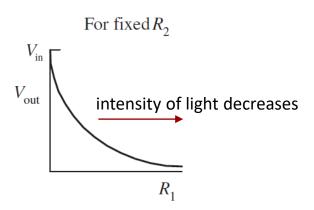
A voltage divider is usually used when using the photoresistor with a microcontroller.





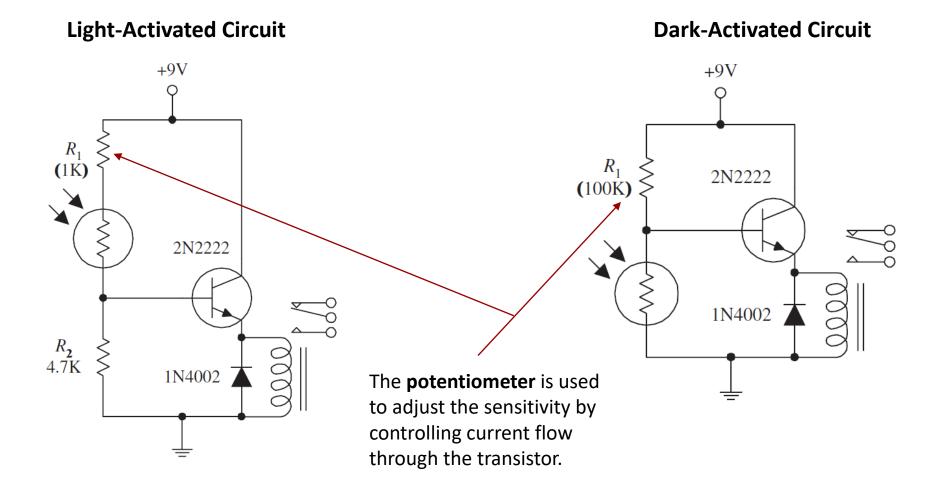
$$V_{
m out} = rac{R_2}{R_1 + R_2} V_{
m in}$$





Stress, Strain, and Force

### **Application: Light/Dark-Activated Relay**



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**Light Sensors** 

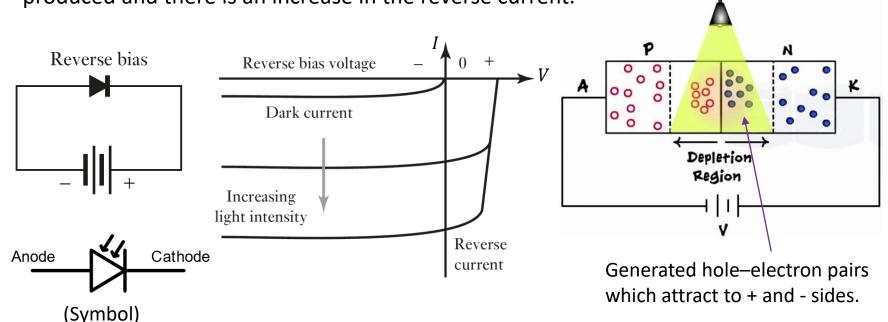
**Light Sensors** 

### **Photodiode**

Photodiode is semiconductor junction diode which is always connected into a circuit in reverse bias mode, hence, it have a wide depletion region.

Photodiodes are designed to detect photons and can be used in circuits to sense light.

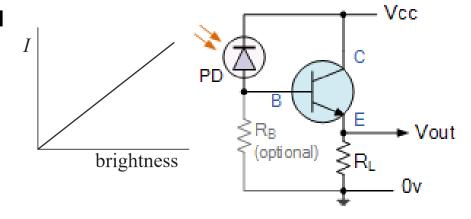
• With no incident light, the reverse current is almost negligible and is called the **dark** current. When light (photon) falls on the junction, extra hole–electron pairs are produced and there is an increase in the reverse current.



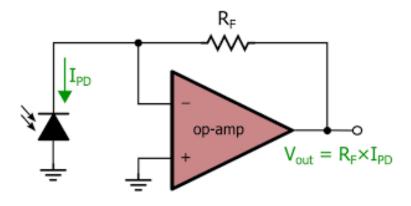
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### **Photodiode**

- The reverse current is **linearly proportional** to the intensity of the light.
- They have very **fast response** to light.



• Amplification is required as the current is very small.

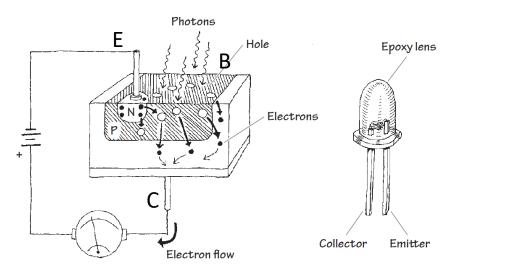


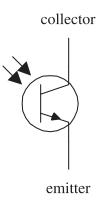
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### **Phototransistor**

**Phototransistors** are light-sensitive transistors.

- A bipolar phototransistor resembles a **BJT** with its Base lead (B) removed and replaced with a light-sensitive surface area (a large **p-type** semiconductor).
- When this surface area is kept dark, there is a very small collector-to-emitter current.
   However, when this surface area is exposed to light, a small base current is generated that is directly proportional to the light intensity and controls a much larger current flows through the collector-to-emitter region.
- Phototransistor can be more sensitive than photodiodes, although it is slower to respond.





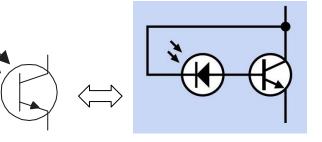
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**Light Sensors** 

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### **Phototransistor**

 A phototransistor is functionally similar to a photodiode controlling an ordinary transistor.



- Photodarlington is a phototransistor connected in a Darlington arrangement with a conventional transistor in an integrated package.
  - They give a **higher collector current** for a given light intensity.
  - They are much **more sensitive** to light than ordinary phototransistors.
  - They tend to have **slower response** times.
  - These devices may or may not come with a base lead.

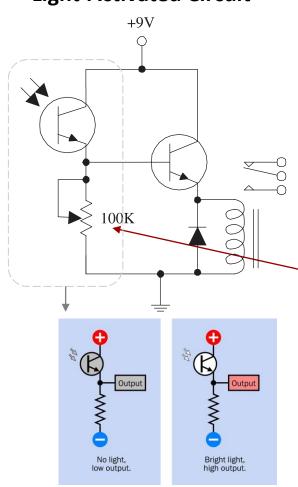
Other Kinds of Phototransistors are Three-Lead Phototransistor and PhotoFETs.

### **Application: Light/Dark-Activated Relay**

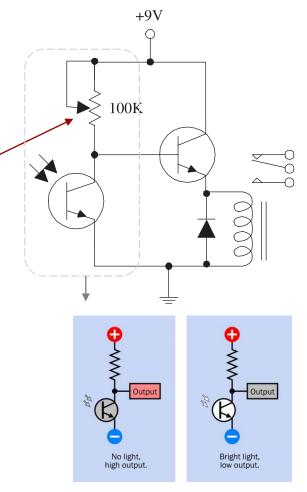
#### **Light-Activated Circuit**

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#### **Dark-Activated Circuit**



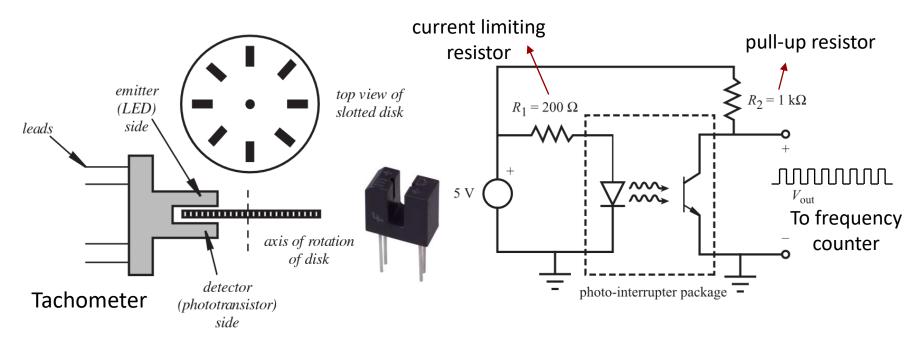
The 100k potentiometer is

by controlling current flow through the phototransistor.

used to adjust the sensitivity

# **Application: Simple Encoder**

To track the **angular position or velocity** of shaft of a motor, a slotted disk connected to the shaft and an **LED-phototransistor pair** is used. The LED produces a beam of light to trigger the phototransistor into conduction and it can be broken or interrupted by rotation of the disk. Each slot in the disk provides a digital pulse as it interrupts the light beam during rotation. A **frequency counter** is used to count the number of electrical pulses generated. The number of pulses provides the measure of rotation.



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Selection of Sensors

# **Temperature**

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### Temperature Measurement

**Temperature** can be measured by measuring quantities such as expansion or contraction of solids, liquids, or gases, electrical resistance of conductors and semiconductors, thermoelectric EMFs, strain, pressure, and volume.

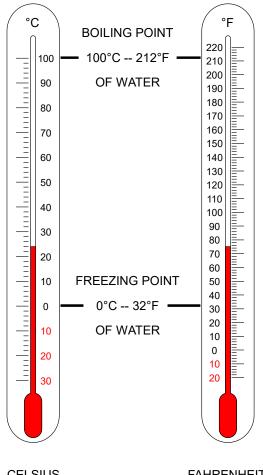
#### **Temperature units:**

Stress, Strain, and Force

$$T_C = T_K - 273.15$$

$$T_F = (9/5)T_C + 32$$

$$T_R = T_F + 459.67$$

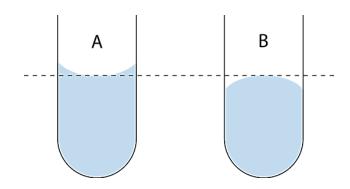


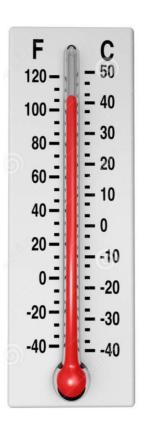
**CELSIUS FAHRENHEIT** 

# **Liquid-in-Glass Thermometer**

It is simple **nonelectrical** temperature-measuring device. It typically uses **alcohol** or **mercury** (Hg) as the working fluid, which expands and contracts relative to the glass container.

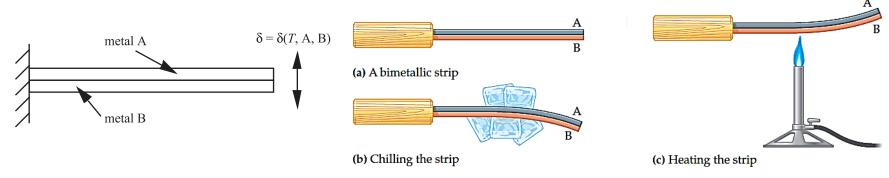
- The upper range is usually on the order of 300°C (600°F).
- Because readings are made visually, and there can be a meniscus at the top of the working fluid, measurements must be made carefully.



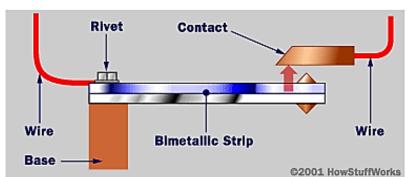


# **Bimetallic Strip**

**Bimetallic Strip** is a **nonelectrical** temperature-measuring device that is composed of two or more metal layers having different **coefficients of thermal expansion** and permanently bonded together. Due to the difference in the thermal expansions of the metal layers, the structure will deform when the temperature changes.



 Bimetallic strips are used as a temperaturecontrolled switch in thermostats where the mechanical motion of the strip makes or breaks an electrical contact.



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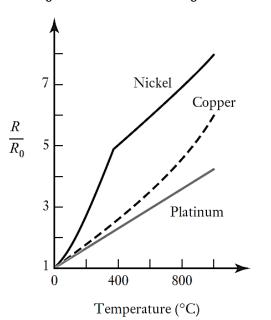
# Resistance Temperature Detector (RTD)

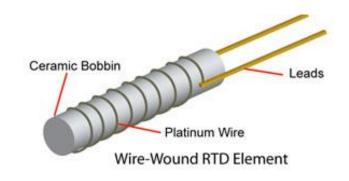
**RTD** is constructed of **metallic** wire wound around a ceramic or glass core and hermetically sealed.

• The resistance of the metallic wire increases with temperature.  $R = R_0[1 + \alpha(T - T_0)]$ 

 $T_0$ : reference temperature (usually 0°C),

 $R_0$ : resistance at  $T_0$ ,  $\alpha$ : calibration constant







Thin-Film RTD Element

- The most common metal is **Platinum** (Pt) because of its high melting point, resistance to oxidation, predictable temperature characteristics, and stable calibration values [Operating range: -220 °C to 750 °C]. (linear)
- Lower cost **Nickel** (Ni) and **Copper** (Cu) types are also available, but they have narrower operating ranges.

(nonlinear: 2<sup>nd</sup> or 3<sup>rd</sup> order polynomial)

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**Light Sensors** 

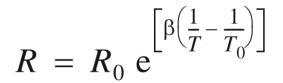
### **Thermistor**

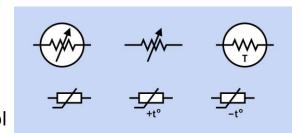
A **Thermistor** is a **semiconductor** device whose resistance changes **exponentially** with temperature.

 $T_0$ : reference temperature,

 $R_0$ : resistance at  $T_0$ ,

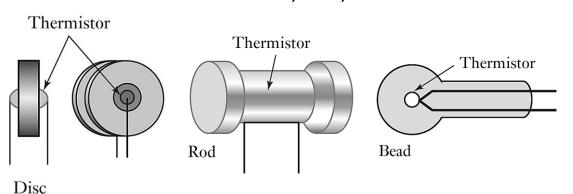
 $\beta$ : calibration constant (characteristic temperature)





Symbol

**More common forms**: bead, disc, and rod.





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**Light Sensors** 

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### **Thermistor**

#### **Thermistors** are of two opposite fundamental types:

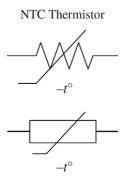
- NTC (Negative Temperature Coefficient): Resistance decreases as temperature rises.
- PTC (Positive Temperature Coefficient): Resistance increases as temperature rises.

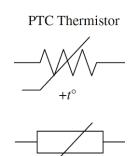
#### **Advantages of Thermistors:**

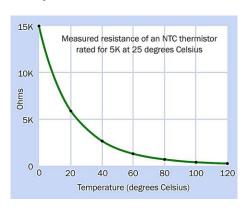
- A well-calibrated thermistor can be more accurate than a typical RTD.
- They are rugged and can be very small.
- They respond very rapidly to changes in temperature.

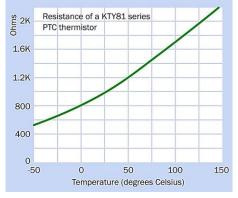
#### **Disadvantages of Thermistors:**

- They give very large changes in resistance per degree change in temperature (non-linearity).
- They have much narrower operating ranges than RTDs.







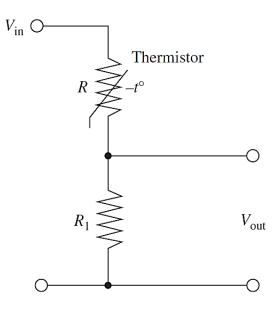


# **Using Thermistors & RTDs**

To use a thermistor or RTD as a thermometer for input to a microcontroller, a voltage is required that can be measured by the analog-to-digital converter (ADC) of the microcontroller.

• A typical circuit is using a voltage divider with a fixed-value resistor of the same value as  $R_0$ .

$$V_{\text{out}} = \frac{R_1}{R_1 + R} V_{\text{in}}$$



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### **Thermodiode**

In a **Thermodiode**, when the temperature of doped semiconductors changes, the mobility of their **charge carriers** changes, and this affects the rate at which electrons and holes can diffuse across a p-n junction.

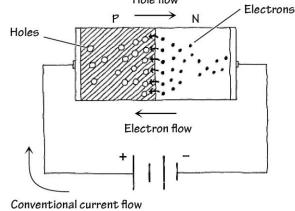
 $I_D = I_0 \left( e^{\frac{q \cdot D}{kT}} - 1 \right)$ k Boltzmann's constant. q charge of one electron,  $I_0$  reverse saturation current,  $I_D$  current through the junction,  $V_D$  forward bias voltage across the junction, T absolute temperature of the junction (Kelvin).

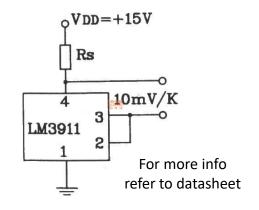
 $V_D = \frac{kT}{a} \ln \left( \frac{I_D}{I_O} + 1 \right)$ 

By taking logarithms:

For a constant current,  $V_D$  is linearly proportional to T (Kelvin).

 Diodes for use as temperature sensors, together with the necessary signal conditioning, are supplied as ICs, e.g., LM3911.

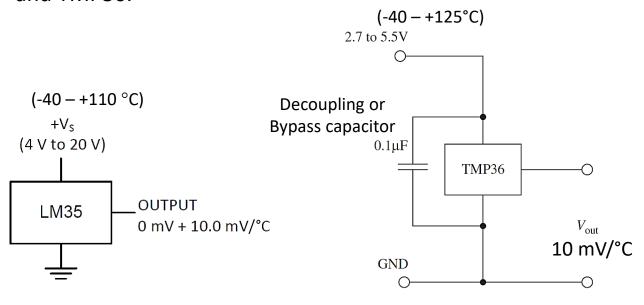


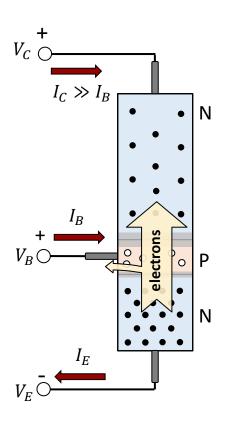


### **Thermotransistor**

In a **Thermotransistor**, the voltage across the junction between the **base** and the **emitter** depends on the temperature and can be used as a measure of temperature.

• Transistors for use as temperature sensors, together with the necessary signal conditioning, are supplied as ICs, e.g., LM35, and TMP36.

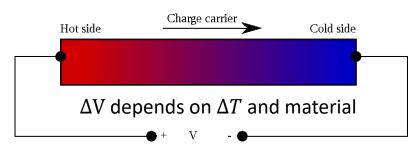




Stress, Strain, and Force

# **Thermocouple**

When one end of a piece of metallic wire is maintained at a temperature  $(T_x)$  that is different from the other end  $(T_y)$ , the temperature gradient along the wire creates a small electromotive force (EMF) that causes a difference in electrical potential between two ends of the wire. This is known as **Seebeck Effect**.



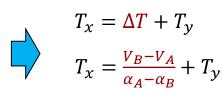
Two dissimilar metals in contact form a **thermoelectric junction**.

• Basic principles of a thermocouple:

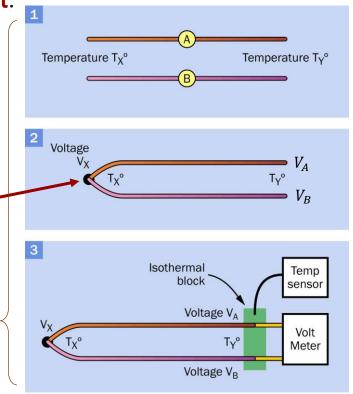
$$V_{x} - V_{A} = \alpha_{A} \Delta T$$

$$V_{x} - V_{B} = \alpha_{B} \Delta T$$

$$V_{B} - V_{A} = (\alpha_{A} - \alpha_{B}) \Delta T$$



 $\alpha_A$ ,  $\alpha_B$ : Seebeck coefficients

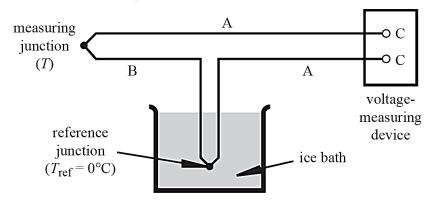


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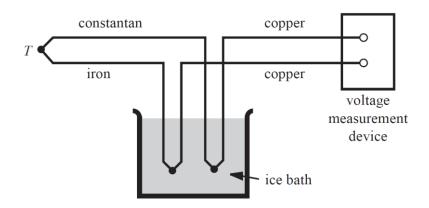
### **Thermocouple Configurations for Measurements**

**Standard Configuration**: It consists of wires of two metals, A and B, attached to a voltage-measuring device with terminals made of metal C and at the same temperature. A convenient reference temperature is 0°C (ice-water mixture).

 An alternative to using an ice bath is a semiconductor reference (e.g., a thermistor), which electrically establishes the reference temperature.



**Two-reference junction configuration**: It allows independent choice of the leadwire metal. Copper is a good choice for leadwires, since it is inexpensive.

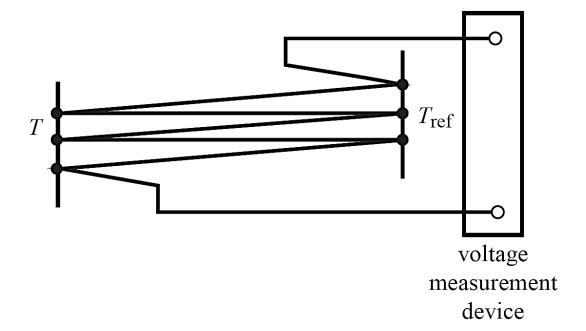


Stress, Strain, and Force



## **Thermopile**

**Thermopile** combines N pairs of junctions, resulting in a voltage N times that of a single pair. If the measuring junctions (at T) are at different temperatures, the output would represent the average of these temperatures.

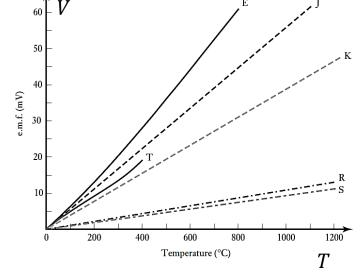


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# **Common Thermocouples**

The six most commonly used thermocouple metal pairs have different ranges and sensitivities are denoted by the letters **E**, **J**, **K**, **R**, **S**, and **T**. The 0°C reference junction calibration for each of the types is **nonlinear** and can be approximated with a polynomial.

$$V = kT + bT^2 \quad \text{or} \quad T = \sum_{i=1}^{9} c_i V^i$$



Thermocouples are generally mounted in a sheath to give them mechanical and chemical protection. However, the sheath reduces the response time of the thermocouple.

Ref.	Materials	Range (°C)	(μV/°C)
В	Platinum 30%	0 to 1800	3
	rhodium/platinum 6% rhodium		
E	Chromel/constantan	-200 to $1000$	63
J	Iron/constantan	-200 to 900	53
K	Chromel/alumel	-200 to 1300	41
N	Nirosil/nisil	-200 to 1300	28
R	Platinum/platinum 13% rhodium	0 to 1400	6
S	Platinum/platinum 10% rhodium	0 to 1400	6
T	Copper/constantan	-200 to 400	43

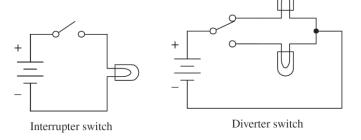
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# **Inputting Data by Switches**

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### **Mechanical Switches**

**Mechanical Switches** consist of one or more pairs of contacts which can be **mechanically** closed or opened and in doing so make or break electrical circuits.



**Momentary-Contact** switches (like pushbutton switches) are used when it is necessary to only **momentarily** open or close a connection. These switches come in either **Normally Closed (NC)** or **Normally Open (NO)** forms

- NC switch acts as a closed circuit when left untouched.
- NO switch acts as an open circuit when left untouched.



Switches can be classified based on their **shape** or **number of Poles and Throws**.

- Pole (P): Number of separate circuits that can be completed by the same switching action.
- Throw (T): Number of individual contacts for each pole.

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### **Switch Types Based on Shape**

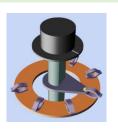
#### Slide Switch



#### **Pushbutton Switch**



#### **Rotary Switch**





**Toggle Switch** 

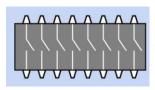


**Rocker Switch** 





**DIP Switch** 





**Binary-Coded Switch** 



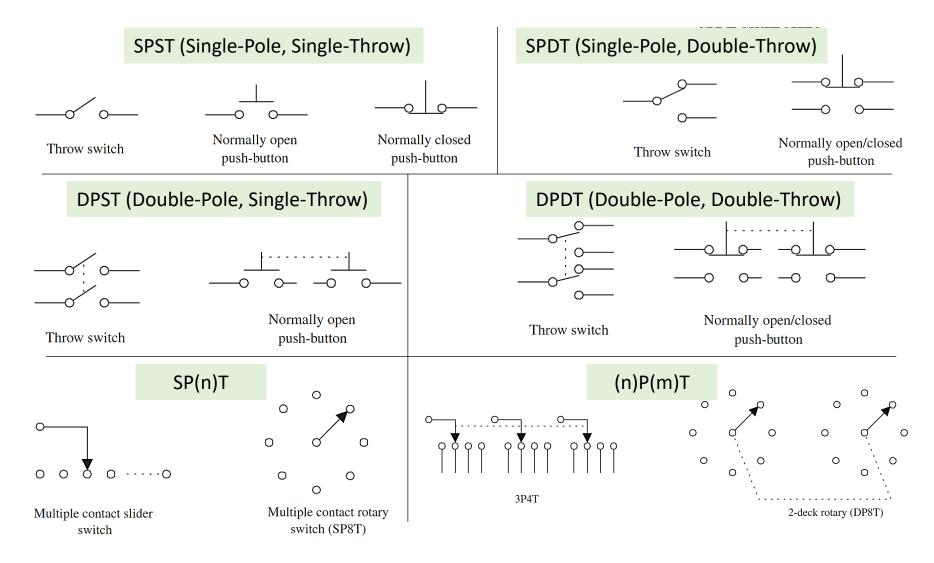
Position	Pin 1	Pin 2	Pin 3	Pin 4
0	•	•	•	•
1	•	•	•	•
2	•	•	•	•
3	•	•	•	•
4	•	•	•	•

#### Center-Off Position Switch

It has an additional "off" position located between the two "on" positions.



# **Switch Types Based on P & T**



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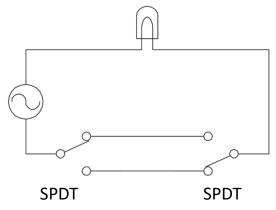
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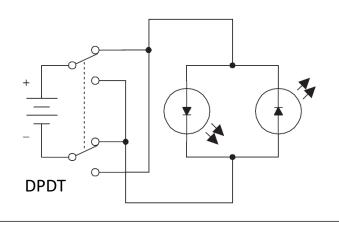
# **Simple Applications**

#### **Dual-Location On/Off Switching Network**

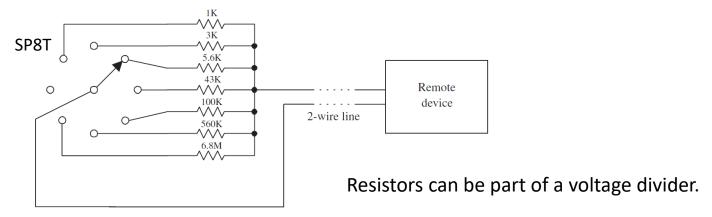


This setup is frequently used in household wiring applications.

#### **Current-Flow Reversal**



#### Multiple Selection Control of a Voltage-Sensitive Device via a Two-Wire Line



### **Switch Bounce**

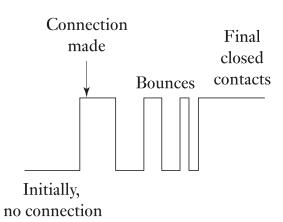
When two metal contacts extremely rapid in a mechanical switch (e.g., in a momentarycontact switch), microscopic vibrations occur that cause brief interruptions before the contacts settle (after about some 20 ms). While this phenomenon is not perceptible to human senses, it can be perceived as a series of multiple pulses by a logic chip (e.g., microprocessor). Similarly, when a mechanical switch is opened, bouncing can occur. To overcome this problem either hardware solutions or software solutions can be used to debounce a switch that drives a logic input.

> SR flip-flop D flip-flop

Schmitt trigger







A piece of code in the Microcontroller

Selection of Sensors

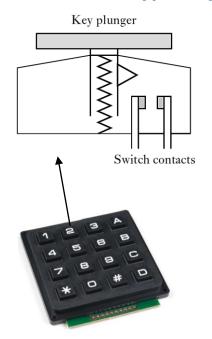
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O +5 V

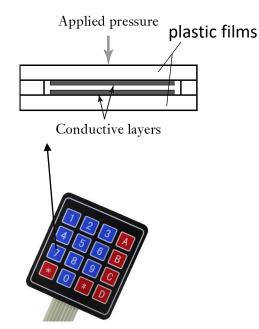
# Keypad

- A Keypad is an array of switches.
- Switches can be **contact-type**, **membrane**, or **piezoelectric**.

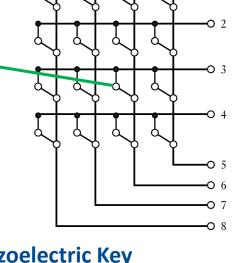
#### **Contact-type Key**



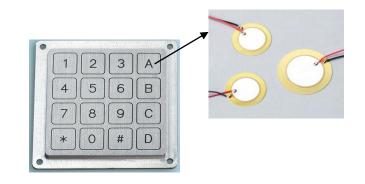
#### **Membrane Key**



#### By pressing, 3 & 6 become 5V



#### **Piezoelectric Key**



Stress, Strain, and Force

**Selection of Sensors** 

# **Selection of Sensors**

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### **Factors To Be Considered**

- (1) Nature of Sensor Input and Measurement Requirement (variable to be measured, its nominal value, values range, required accuracy, measurement speed, reliability, resolution, environmental conditions [temperature, pressure, moist, corrosion, EM interferences, etc.]).
- (2) Nature of Sensor Output (required signal conditioning, communication protocol, data acquisition card, signal level, data presentation system).
- (3) Possible Sensors (direct or indirect measurements, active or passive sensors, sensor range, accuracy, linearity, response time, error, sensitivity, reliability, durability, maintainability, lifetime, wear, service, physical size, weight, implementation complexity, power supply requirements [battery, 110/220 V AC, USB-port], availability, supplier, cost).



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